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Simon Min Sze (Chinese: 施敏; pinyin: Shī Mǐn; born 1936) is a Chinese-American electrical engineer. He is best known for inventing the floating-gate MOSFET with Dawon Kahng in 1967.. Biography. Sze was born in Nanjing, China, and grew up in Taiwan. After graduating from the National Taiwan University in 1957, he received a master's degree from the University of Washington in 1960 and a ...

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